Docket No.: 0171-1079PUS1 (PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Hiroki YOSHIKAWA et al.

Application No.: 10/811,924 Confirmation No.: 3156

Filed: March 30, 2004 Art Unit: 1756

For: PHOTOMASK BLANK, PHOTOMASK, AND Examiner: S. D. Rosasco

METHOD OF MANUFACTURE

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated April 16, 2007, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.